



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Nathan R. Brown

Serial No.: 10/715,248

Filed: November 17, 2003

For: POLISHING SYSTEMS FOR USE
WITH SEMICONDUCTOR SUBSTRATES
INCLUDING DIFFERENTIAL PRESSURE
APPLICATION APPARATUS

Confirmation No.: 4988

Examiner: D. Thomas

Group Art Unit: 3723

Attorney Docket No.: 2269-4375.2US
(99-1029.02/US)

Notice of Allowance Mailed:

November 10, 2004

Express Mail Mailing Label No.: EL 994826066 US

Date of Deposit with USPS: February 8, 2005

Person making Deposit: Steve Wong

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Amendments to the Specification begin on page 3 of this paper.

A Listing of the Claims begins on page 6 of this paper.

Remarks begin on page 9 of this paper.